

SEP 23 2004

Appl. No. 10/607,869

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/607,869
Filing Date June 27, 2003
Inventor..... Zhongze Wang
Assignee..... Micron Technology, Inc.
Group Art Unit..... 2812
Examiner Jennifer M. Kennedy
Attorney's Docket No. MI22-2343
Customer No. 021567
Title: Method of Forming Silicon-on-Insulator Comprising Integrated Circuitry

RESPONSE TO JUNE 25, 2004 OFFICE ACTION

To: Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENTS**Introductory Comments**

In reply to the Office Action of June 25, 2004, applicant amends and remarks as follows.